

Docket No. 42479-9400

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Satoshi Hayashi et al.

Serial No.: 10/581,578

Filed: December 26, 2006

For: ANION ADSORBING CARBON MATERIAL,
AS WELL AS MANUFACTURING METHOD
AND MANUFACTURING FACILITIES FOR
SAME

Group Art Unit: 1793

Confirmation No.: 4920

June 3, 2008

Costa Mesa, California 92626

**SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following reference which was found during the prosecution of a co-pending Chinese patent application:

Chinese Publication No. 1040185A w/English translation of claims.

A copy of the reference and Form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing the information disclosure statement.

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If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

SNELL & WILMER L.L.P.



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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional)		Application Number		
				42479-9400		10/581,578		
				Applicant(s)				
				Satoshi Hayashi et al.				
				Filing Date		Group Art Unit		
				December 26, 2006		1793		
U. S. PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
U. S. PATENT APPLICATION PUBLICATIONS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		1040185A	3.7.1990	China w/English translation of claims			X	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
EXAMINER /Brian Walck/				DATE CONSIDERED 01/31/2009				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								